

INFORMATION DISCLOSURE STATEMENT BY APPLICANTS PTO-1449

Attorney Docket No. 10191/4621	Seria No. / 578 971 To Be Assigned		
Applicant(s) Karsten STREHL			
Filing Date Herewith	Group Art Unit To Be Assigned		

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT/ PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE
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FOREIGN PATENT DOCUMENTS

EXAMINER'S	DOCUMENT			CLASS	SUBCLASS	TRANSLATION	
INITIALS	NUMBER	DATE	COUNTRY			YES	NO
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OTHER DOCUMENTS

XAMINER'S INITIALS	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
الالله	International Search Report, PCT International Patent Application No. PCT/EP2004/012735, dated August 29, 2005
	Written Opinion of the International Searching Authority, PCT International Patent Application PCT/EP2004/012735, dated August 29, 2005
	A. Rolfsmeir "ASAM MCD Interfaces in the ECU Software Development Process," ASAM Conference, September 25, 2001, pp. 1 to24, XP002291528"
	Anonymous, "ASAM Schnittstellen," Elektronik Industrie, Vol. 9 1999, pp. 90 to 93, XP002291529*
	ASAM E.V., "Introduction ASAM-GDI," October 2000, pp.1 to 33, XP002291544*
	ASAM E.V., "ASAM Einfuehrung," April 2001, p. 26, XP002291530"
	"ASCET-sACET-SD White Paper," September 2002, pp. 1 to 29, XP002286572*
4	S. Seungwoo et al., "Debugging Protocol for Remote Cross Development Environment," Proceedings Seventh International Conference on Real-Time Computing Systems and Applications ICCE Computer Society, 2001, pp. 394 to 398, XP002340088*
1 .10	K. Lee, et al., "A Design and Implementation of a Remote Debugging Environment for Embedded Internet Software," Languages, Compliers and Tools for Embedded Systems, ACMSigplan Workshop LCTES, 2001 Proceedings (Lecture Notes in Computer Science vol. 1985), pp. 199 to 203, XP002340089
1 .10	and Tools for Embedded Systems, ACM Sigplan Workshop LCTES ;2001 Proceedings (Lecture Notes in Computer Sc 199 to 203, XP002340089*

EXAMINER DATE CONSIDERED 8/29/07

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.